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Patent

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Customer No. 31561
Docket No. 9788-US-PA
Application No.: 10/065,874

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : Chia-Tien Peng
Application No. : 10/065,874
Filed : 2002/11/27
For : METHOD FOR FABRICATING POLYSILICON LAYER
Examiner : Fuller, Eric B
Art Unit : 1762

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Enclosed are a PTO Form 1449 listing 1 reference of the above-identified application, a copy of the aforesaid reference, and its English translation. Pursuant to 37 CFR §1.56, Applicant is submitting the reference in compliance with his duty of disclosure. The Examiner is requested to make this reference a citation of official record.

No fee is believed to be due for this submission. However, the Commissioner is authorized to charge any fees required in connection with the submission of the IDS reference to Account No. 50-2620 (Order No.: 9788-US-PA)

The submission of the reference should not be interpreted as admitting it as prior art.

Respectfully Submitted,
JIANG CHYUN Intellectual Property Office

Date: June 22, 2005

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